

Search Notes

Application/Control No.

10/798,365

Examiner

John S. Chu

Applicant(s)/Patent under
Reexamination

TAKAMIYA

Art Unit

1752

SEARCHED

Class	Subclass	Date	Examiner
430	331	9/2006	JSC
430	270.1		
430	302		
101	465		
101	467		

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
updated	9/2006	JSC

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
430	331,270.1	9/2006	JSC
430	302		
101	465,467	L	L